

## **INFORMATION DISCLOSURE CITATION**

		t e	Not Yet Assigned	·=====================================
Applicants Kenji KA	WANO et al.			226.8
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U.S. PATENT DOCUMENTS						
Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
M	6,072,162	06/06/00	ITO et al.			
M	6,191,397 B1	02/20/01	HAYASAKI et al.			· · · · · · · · · · · · · · · · · · ·
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	Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
MI	11-38644	02/12/99	JAPAN			ABSTRACT
M	2000-146444	05/26/00	JAPAN			ABSTRACT

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)					
MD	ITO, S. et al., "Heating Method", U.S. Serial No.: 09/573,227, Filed: May 19, 2000, Specification - 46 pages, and 7 sheets of drawings				
po	ITO, S. et al., "Device and Method for Heating Substrate, and Method for Treating Substrate", U.S. Serial No.: 09/352,323, Filed: July 12, 1999, Specification - 45 pages, and 7 sheets of drawings				
PVD	HAYASAKI, K. et al., "Heating Device, Method for Evaluating Heating Device and Pattern Forming Method", U.S. Serial No.: 09/345,749, Filed: July 1, 1999, Specification - 78 pages, and 16 sheets of drawings				
no	KIHARA, N. et al., "Effect of Acid Evaporation in Chemically Amplified Resists on Insoluble Layer Formation", Journal of Photopolymer Science and Technology, Vol. 8, No. 4, pp. 561-570, (1995).				

Examiner I brown hand being		Date Considered 03/18/2004	
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			
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